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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/677,478  
Filing Date ..... October 2, 2000  
Inventor ..... Guy T. Blalock  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1765  
Examiner ..... Lan Vinh  
Attorney's Docket No. .... MI22-1544  
Title: Plasma Etching Methods

**RESPONSE TO AUGUST 28, 2002 OFFICE ACTION**

To: Box Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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RECEIVED  
JUN - 6 2003  
TO: DIRECTOR, TPO

**AMENDMENTS**

**In the Claims**

Please replace the claims with the following clean version of the entire set of pending claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i). Cancel all previous versions of any pending claim.

A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by

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02 FC:1201 44.00 OP  
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